Docket No.: H6810.0011/P011 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Masahiko Ando, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: July 11; 2001

Examiner: Not Yet Assigned

For:

THIN FILM TRANSISTOR, LIQUID

CRYSTAL DISPLAY AND

MANUFACTURING METHOD

THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

follows:

Preliminary to examination, please amend the above-referenced application as

IN THE SPECIFICATION:

Page 8, rewrite the paragraph beginning on line 1 as follows:

A Figs. 1(a) through 1(e) illustrate a thin film transistor and the manufacturing process thereof according to a first embodiment;

Page 8, rewrite the paragraph beginning on line 6 as follows:

 \mathbb{V} Figs. 3(a) through 3(e) illustrate a thin film transistor and the manufacturing process thereof according to a second embodiment;

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Page 8, rewrite the paragraphs beginning on lines 10 and 12 as follows:

Figs. 5(a) through 5(f) illustrate a thin film transistor and the manufacturing process thereof according to a third embodiment; and

Figs. 6(a) through 6(d) illustrate a conventional channel etched type thin film transistor and the manufacturing steps thereof.